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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/721,719 Confirmation No.: 5752  
Applicant : Dingjun Wu  
Filed : 11/25/2003  
For : METHOD FOR CLEANING DEPOSITION CHAMBERS FOR HIGH  
DIELECTRIC CONSTANT MATERIALS  
  
Art Unit : 3749  
Examiner : Kenneth Rinehart  
  
Docket No. : 06469 USA  
Customer No. : 23543

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Rosaleen P. Morris-Oskanian  
Signature of person mailing paper

**Amendment and Response to Final Office Action**

Sir:

Enclosed herewith is an amendment and response to the Office Action mailed 8 April 2005. Please amend the above-identified application as follows:

- Amendments to the Specification** begin on page \_\_\_\_\_ of this paper.
- Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.
- Amendments to the Drawings** begin on page \_\_\_\_\_ of this paper and include an attached replacement sheet(s).
- Amendments to the Abstract** are on page \_\_\_\_\_ of this paper. A clean version of the Abstract is on page \_\_\_\_\_ of this paper.
- Remarks/Arguments** begin on page 7 of this paper.